

7/19/23/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): GUOHENG ZHAO ET AL.
Assignee: KLA-TENCOR TECHNOLOGIES CORPORATION
Title: IMPROVED SYSTEM FOR MEASURING PERIODIC STRUCTURES
Serial No.: 09/742,029 Filing Date: December 20, 2000
Examiner: Unknown Group Art Unit: 2877
Docket No.: M-10696 US

San Jose, California

Aug ~~July~~ 1, 2001

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying PTO Form-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

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8/1/01
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Respectfully submitted,

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